

FIGURE 1A (PRIOR ART)

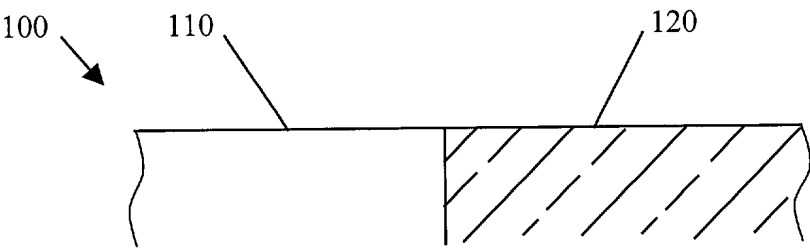


FIGURE 1B (PRIOR ART)

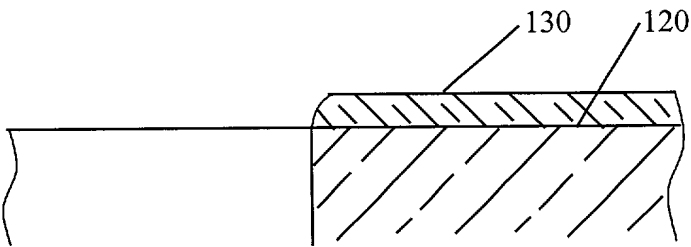


FIGURE 1C (PRIOR ART)

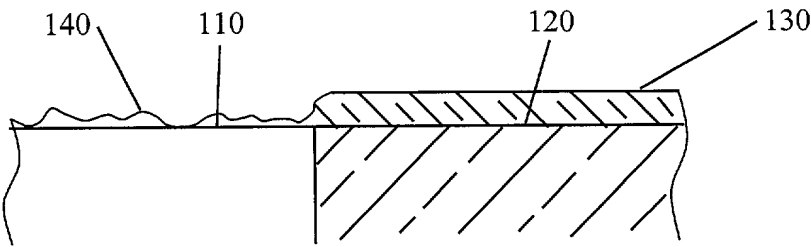


FIGURE 2A

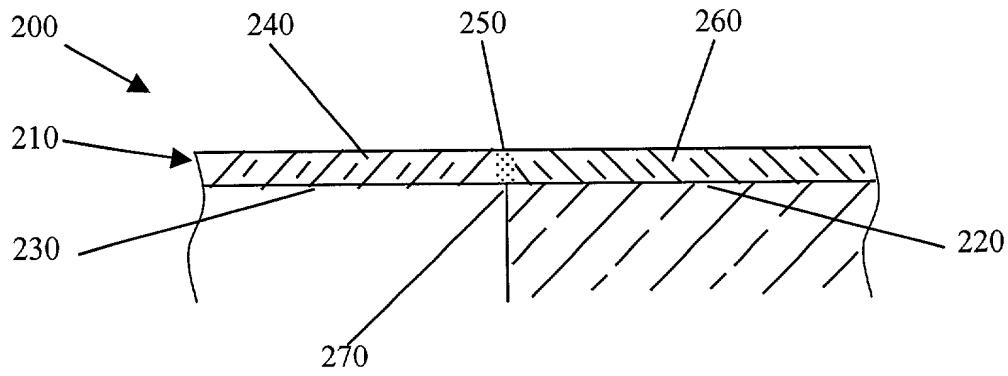


FIGURE 2B

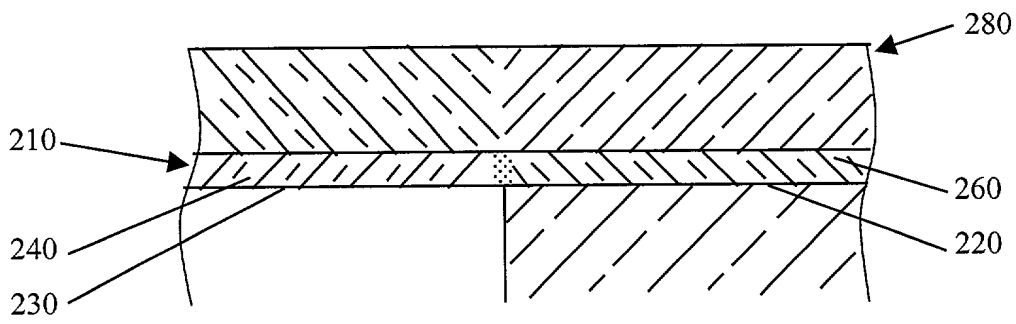


FIGURE 3A

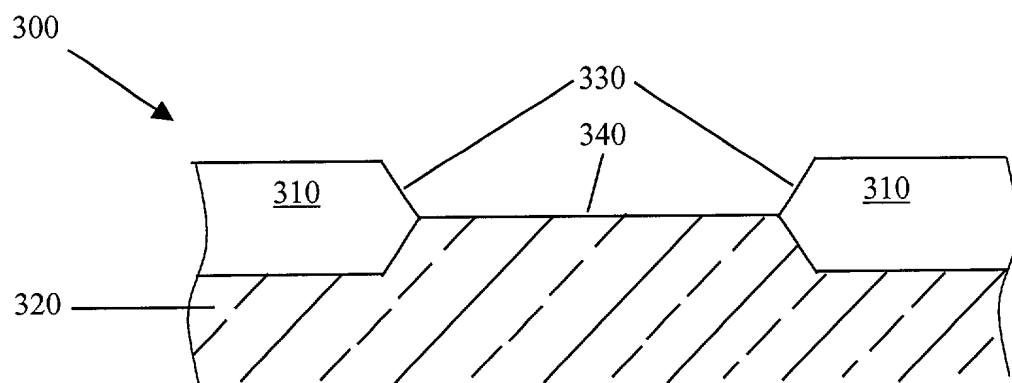


FIGURE 3B

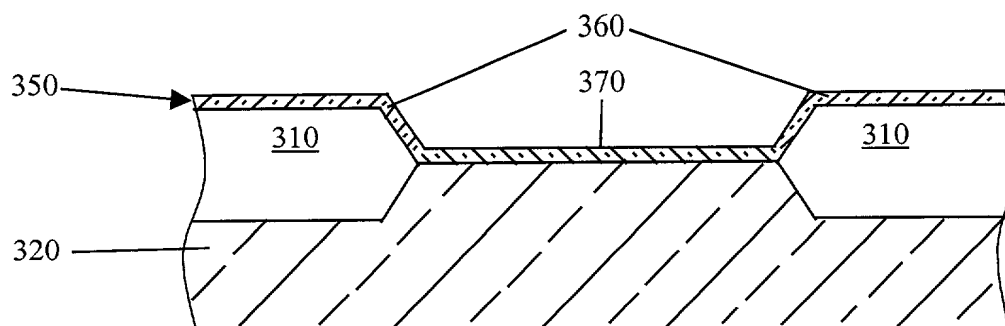


FIGURE 3C

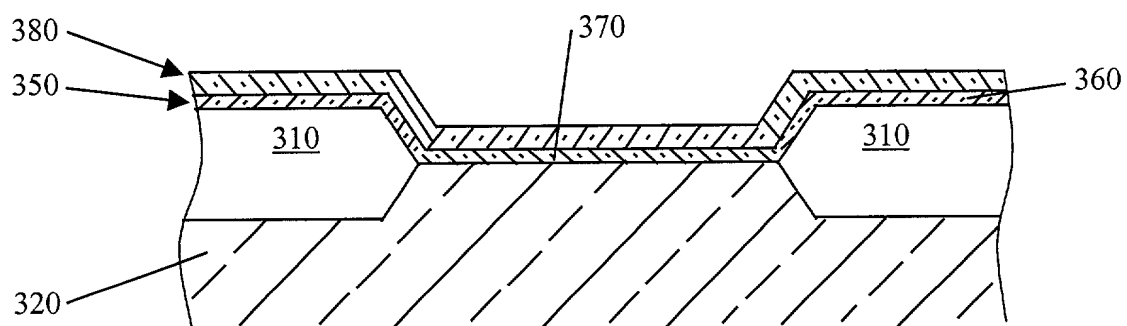
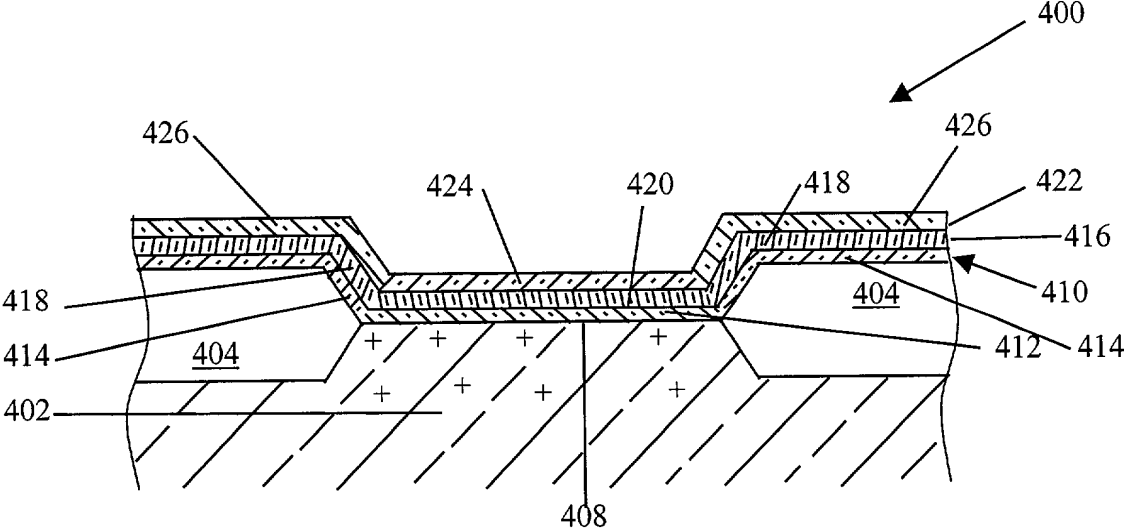


FIGURE 4



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FIGURE 5A

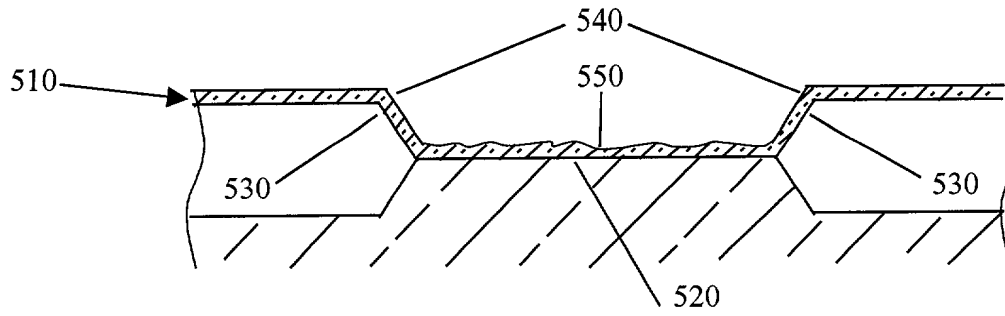


FIGURE 5B

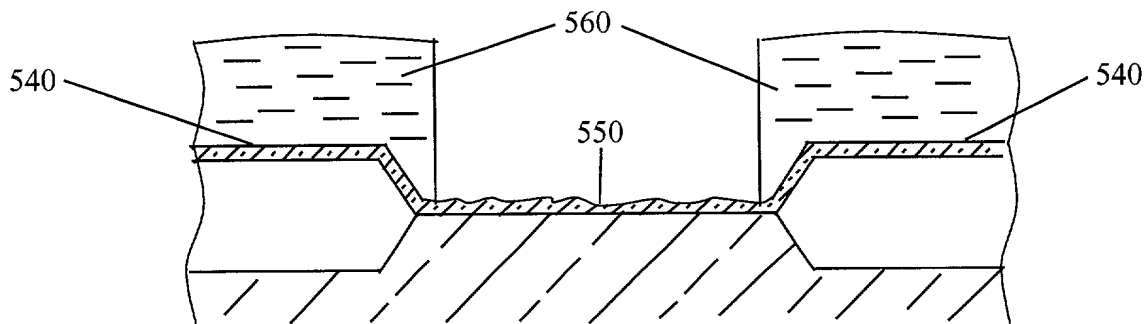


FIGURE 5C

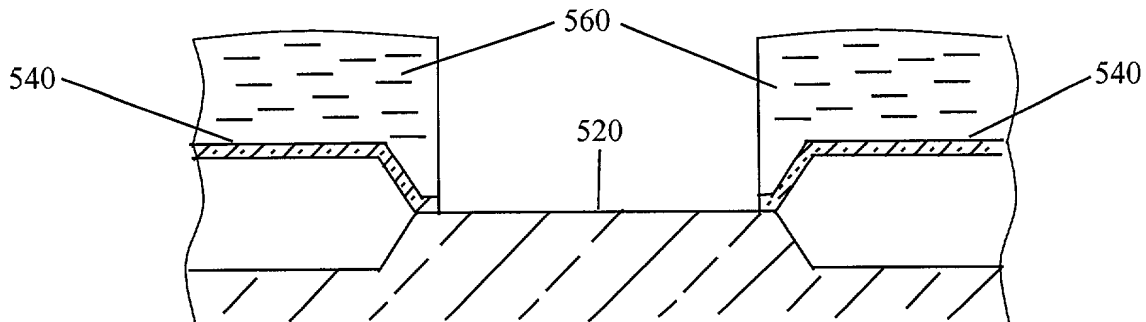


FIGURE 5D

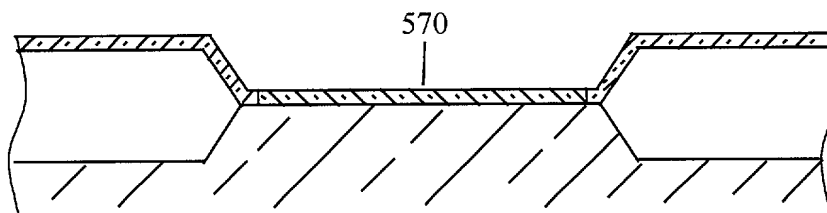
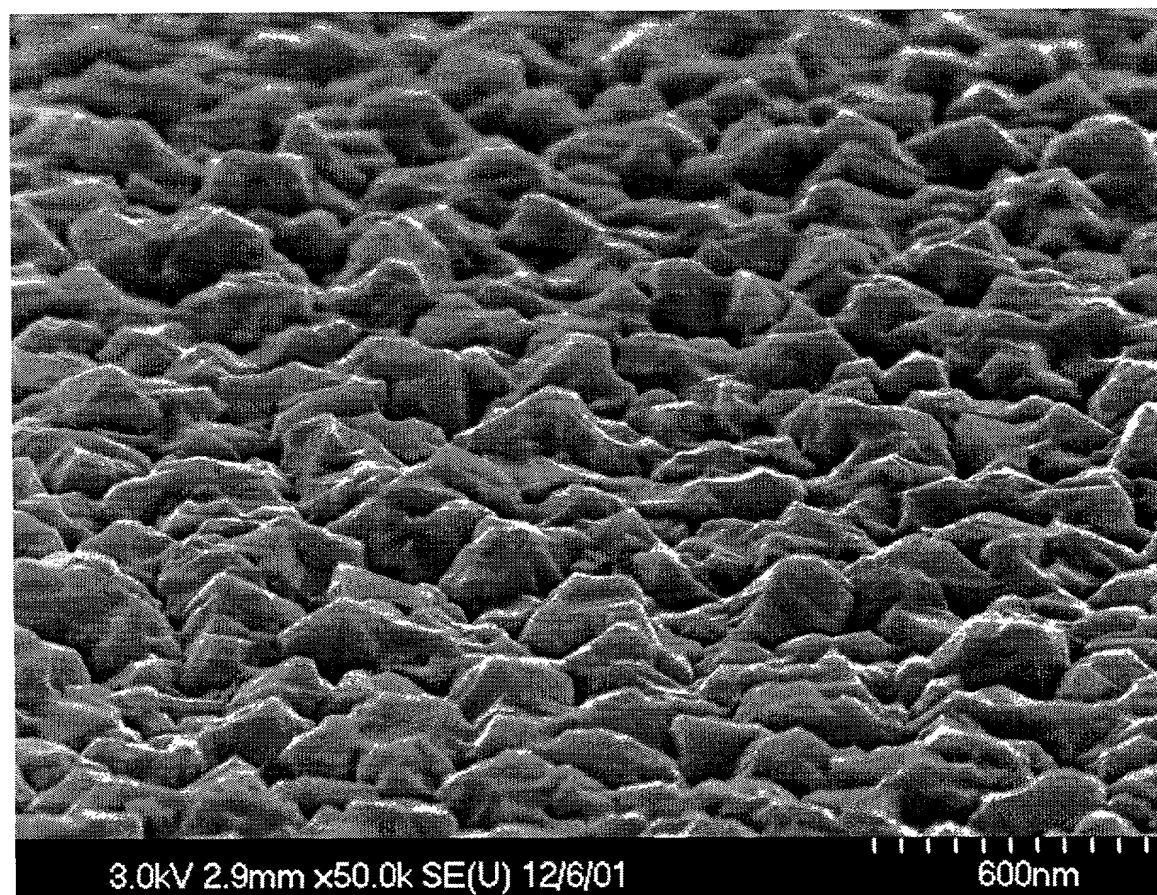


FIGURE 6
SEM Photomicrograph of Si-Ge Film Deposited Using Silane and Germane



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FIGURE 7
SEM Photomicrograph of Si-Ge Film Deposited Using Silane and Germane



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FIGURE 8
SEM Photomicrograph of Si-Ge Film Deposited Using Trisilane and Germane

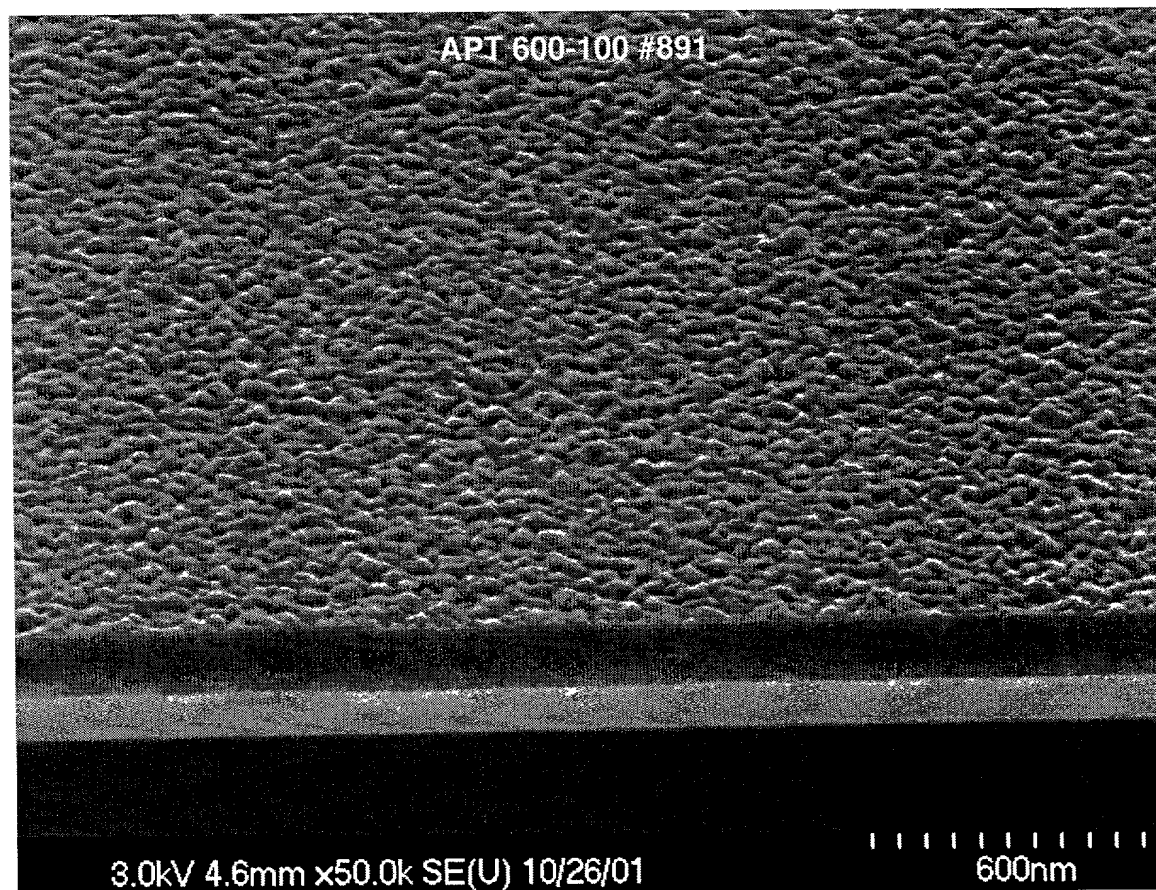


FIGURE 9
SEM Photomicrograph of Si-Ge Film Deposited Using Trisilane and Germane

